

Notice of References Cited	Application/Control No. 10/663,402	Applicant(s)/Patent Under Reexamination FARNWORTH ET AL.	
	Examiner Vivian Chen	Art Unit 1773	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0158343	08-2004	Hiatt et al.	700/118
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wikipedia entry, "Rapid Prototyping" (web printout - 5/23/2006)
	V	"Rapid prototyping Stereolithography, Selective Laser Sintering, and polyjet....", Advanced Materials & Processes, 1-1-2003, (abstract)
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.